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AFM/SEM Comparative Measurements of Graphene





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HITACHI

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Top left, Hydroxyapatite crystals. Sample courtesy of Devin Wu, FEI China and Shanghai Institute of Ceramics. Top right, Shale. Bottom left, Fe/Sn nanoparticles. Bottom right, Self-catalyzed GaAswires. Sample courtesy David Fuster, Andrés Raya, Álvaro San Paulo and Maria Ujue González, IMM Madrid (CNM-CSIC).

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Intermittent contact mode AFM phase images of a thermoplastic polymer as it crystallizes. Clockwise from upper left: t = 0 sec, t = 13 sec, t = 104 sec, and t = 194 sec. Image width $= 1 \ \mu m$.

See article by Winkel et al.

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